



RABIN & BERDO, P.C.

Specializing in Patent, Trademark

And Copyright Law

Suite 500, 1101 14th Street, N.W.

Washington, D.C. 20005

Tel.: (202) 371-8976 Fax: (202) 408-0924

E-Mail: firm@rabinchamp.com

Steven M. Rabin

Robert H. Berdo, Jr.

Phillip G. Avruch

Allen Wood

Qixia Zhang, Pat. Agent (China)

In Affiliation with

Weiss, Moy & Harris, PC

having offices in Arizona and Nevada,

and in Washington, DC with

Rabin & Berdo, PC

January 29, 2004

Mail Stop Patent Application

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Attorney Reference: AI 325

Re: New Patent Application of: Masaru TAKAISHI

Title: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE



Sir:

Please find attached hereto an application for patent that includes:

- ☒ Specification, Claims and Abstract (27 Pages)
- ☒ 3 Sheets of Formal Drawings (Fig. 1 through Fig. 3)
- ☒ Inventor's Declaration and Power of Attorney (3 Pages)
- ☒ Assignment document with cover page (2 Pages)
- ☒ Claim for priority and Priority document
- ☒ Information Disclosure Statement, Form PTO-1449, and copy of one cited reference
- ☒ Form PTO-2038 (1 Page)
- ☒ Fee (see formula below)

Basic Fee \$770/385 \$ 770.00

Additional Fees:

Total number of claims: 9
in excess of 20: 0 times \$18/9 \$ 0.00

Number of independent claims: 1
in excess of 3: 0 times \$86/43 \$ 0.00

Multiple Dependent Claims \$290/145 \$ 0.00

Recording Fee \$40. \$ 40.00

TOTAL FEES FOR THE ABOVE APPLICATION \$ **810.00**

In the event there is attached hereto no credit card form PTO-2038 or check, or there is an insufficient amount, please charge the fee to our Account No. 18-0002 and notify us accordingly.

The right of priority is claimed under 35 USC §119 of Japanese Application No. 2003-051571, filed February 27, 2003.

Respectfully submitted,

Robert H. Berdo, Jr. (Reg. No. 38,075)
(Customer No: 23995)

January 29, 2004

Date: [Signature] (Reg. No. 38,075)

RHB:tz (Reg. No. 23995)